



MS AF
REPLY UNDER
37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1765

PATENT
0033-0701P

IN THE U.S. PATENT AND TRADEMARK OFFICE

OK to enter

Applicant:	Tetsuya NAKABAYASHI et al.	Conf.:	1937
Appl. No.:	09/813,152	Group:	1765
Filed:	March 21, 2001	Examiner:	L. Vinh
For:	SUSCEPTOR AND SURFACE PROCESSING METHOD		

LV
4/13/2004

REPLY UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 29, 2004

Sir:

In reply to the final Office Action dated January 29, 2004, the following remarks are respectfully submitted in connection with the above-identified application.

This reply includes: Remarks.